

In The Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently Amended) Apparatus for applying fluid to a substrate, ~~in particular for glueing inner books, wherein the substrate is movable in a principal direction of movement comprising: relative to the apparatus, and said apparatus comprises~~
~~a first slot nozzle connectable with capable of receiving the fluid from a fluid source and including a first slot nozzle outlet having a width adapted to extend transversely to the principal direction of movement for applying a first fluid film onto a side of the substrate to be coated, and characterized in that the first slot nozzle includes sealing means~~
~~a first movable seal member for adjusting the width of the said first slot nozzle outlet transversely to the principal direction of movement of the substrate.~~

2. (Currently Amended) ~~Apparatus according to The apparatus of claim 1, additionally further comprising:~~
~~a second slot nozzle having a second slot nozzle outlet and capable of receiving the fluid from the connectable with a fluid source, for and applying a second fluid film onto the a side of the substrate to be coated that lies opposite the side coated with the first fluid film by the first slot nozzle.~~

3. (Currently Amended) Apparatus according to The apparatus of claim 2, further comprising:

a second movable seal member for adjusting the width of said second slot nozzle outlet transversely to the principal direction of movement of the substrate.
characterized in that the second slot nozzle comprises sealing means for adjusting the width of the second slot nozzle outlet transversely to the principal direction of movement of the substrate.

4. (Currently Amended) Apparatus according to The apparatus of claim 3,

further comprising:

a third slot nozzle having a third slot nozzle outlet and capable of receiving the fluid from the connectable with a fluid source, for applying a third fluid film onto the a third back surface of the substrate to be coated, in particular the back surface of an inner book.

5. Canceled.

6. (Currently Amended) Apparatus according to one of the preceding claims, characterized in that the first and/or second The apparatus of claim 2 wherein said first and second slot nozzles are movably mounted for adjusting the a gap between the said first and second slot nozzle nozzles.

7. Canceled.

8. (Currently Amended) ~~Apparatus according to one of the preceding claims~~ The apparatus of claim 1, characterized in that the sealing means wherein said first nozzle outlet lies in a plane and said first movable seal member projects out of the said plane of the first nozzle outlet and/or the plane of the second nozzle outlet in the a direction of a the substrate to be coated, in order to limit the thickness of the fluid film applied by the respective said first slot nozzle onto the substrate.

9. (Currently Amended) ~~Apparatus according to one of the preceding claims, The apparatus of claim 1, wherein said characterized in that the first slot nozzle includes a width and said first slot nozzle outlet lies in a plane, and the apparatus further comprises:~~

~~and/or second slot nozzle, if present, and/or third slot nozzle, if present, comprise(s):~~

a fluid passageway extending across the entire width of said first the slot nozzle,

a piston ~~that is~~ movable in the said fluid passageway to seal said fluid passageway ~~the latter~~, and

a sealing body extending within the plane of the said first slot nozzle outlet, said piston and sealing body cooperating to adjust the width of said first slot nozzle outlet transversely to the principal direction of movement of the substrate.

~~wherein the piston and the sealing body co-operate to adjust the width of the slot nozzle outlet transversely to the principal direction of movement of the substrate.~~

10. (Currently Amended) Apparatus according to one of claims 5 -- 9,
characterized in that The apparatus of claim 4, wherein said third slot nozzle outlet has a width and a gap is defined between said first and second slot nozzles, the width of the said third slot nozzle outlet is being limited by the gap between the said first and second slot nozzle nozzles.

11. (Currently Amended) Apparatus according to one of the preceding claims, additionally comprising The apparatus of claim 4, further comprising:
a clamping device for holding the movable substrate.

12. (Currently Amended) Apparatus according to claim 11, additionally The apparatus of claim 11, further comprising:
a lifting means for moving the first and/or the second and/or, if present, the third slot nozzle in the direction of the device configured to move said first, second and third slot nozzles toward and away from said clamping device.

13. Canceled.